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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Thomas A. Figura, Kevin Donohoe, & Thomas Dunbar

Serial No.: 09/470,650

Filed: December 22, 1999

Title: USE OF A PLASMA SOURCE TO FORM A LAYER
DURING THE FORMATION OF A SEMICONDUCTOR DEVICE

§
§ Group Art Unit: 2829
§
§ Examiner: Lisa Kilday
§
§ Atty. Docket: 94-0280.04
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#13
Response
J. White
7-2002

RESPONSE TO THE OFFICE ACTION DATED MARCH 15, 2002

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Certificate of Mailing	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:	
Commissioner for Patents Washington, DC 20231 on	
Date 6/17/02	Signature <i>Susan Jerome</i>

Applicants herein respond to the Office Action dated March 15, 2002.

REMARKS

Claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43 are pending.

Claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43 are rejected.

Applicants request reconsideration of claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43.

I. Rejection of claims under §112

The Examiner rejected claims 1-8, 10-14, 19, 23-24, 29-32, and 36-43 under §112 ¶1, arguing that Applicants should demonstrate the Specification's disclosure of a reasonable number of species representing "today's broad genus encompassing the